

Serial No. 09/256,265

Docket No. 15917-0011

PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kao et al.
Serial No: 09/256,265
Filed: February 23, 1999

Docket No: 15917-0011
Group Art Unit: 2815
Examiner: G. Eckert, II

Election
#3
6-15-99
T. Flowers

For: "Method And Apparatus For Split Gate Source Side Injection Flash Memory Cell And Array With Dedicated Erase Gates"

Examiner G. Eckert II
Group No. 2815
Assistant Commissioner for Patents
Washington, D.C. 20231

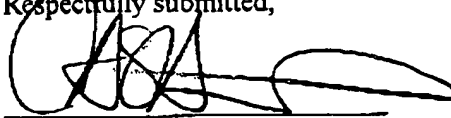
RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement mailed May 10, 1999, Applicant provisionally elects with traverse the claims of Group I; namely, claims 1, 2, and 8-10, drawn to a semiconductor device, classified in class 257, subclass 315.

Applicants respectfully traverses the restriction requirement on the grounds that to be complete, a search for the subject matter of any of the alleged groups would require the same field of search as the other groups. Reconsideration of this requirement is requested.

Respectfully submitted,



Dated: June 9, 1999

Claude A.S. Hamrick
Registration No. 22,586
Attorney for Applicant

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JUN 9 1999

OPPENHEIMER WOLFF & DONNELLY LLP
101 Park Center Plaza, Suite 300
San Jose, California 95113-2237
Telephone: (408) 795-3000
Facsimile: (408) 795-3100

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CERTIFICATE OF MAILING (37 CFR 1.8)

I hereby certify that this correspondence with all attachments is being sent by facsimile transmission to Examiner G. Eckert, II, Group Art Unit 2815, at (703) 308-7382, Assistant Commissioner for Patents, Washington, D.C. 20231 on June 9, 1999 by I Marie Kotsubo.

Date: June 9, 1999


I. Marie Kotsubo

OPPENHEIMER WOLFF & NELLY LLP

FAX COVER LETTER

101 Park Center Plaza
Suite 400
San Jose, California 95113

(408) 795-3000
FAX (408) 795-3100

June 9, 1999

From : Claude A.S. Hamrick
Direct Dial : 408-795-3102
E-Mail : chamrick@owdlaw.com
Re : Serial No. 09/256,265, Filed February 23, 1999; Kao; "Method and Apparatus
For Split Gate Source Side Injection..."; Our Docket No. 15917-0011

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PLEASE RUSH TO EXAMINER ECKERT IMMEDIATELY

Completed by : M. Kotsubo / 3126

TO	COMPANY	PHONE NO.	FAX NO.
Examiner G. Eckert, II	U.S. Patent & Trademark Office; Group Art Unit No. 2815	703-305-2752	703-308-7382

Comments : Dear Examiner Eckert: Please find enclosed a Response to Restriction Requirement for the above-identified matter. Please call me with any comments/questions. Regards,
Claude A.S. Hamrick



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JUN 9 1999

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